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Bib Data Sheet

CONFIRMATION NO. 3353

SERIAL NUMBER 10/751,503	FILING DATE 01/06/2004 RULE	CLASS 438	GROUP ART UNIT 2823	ATTORNEY DOCKET NO. LEEH3016/EM
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APPLICANTS

Hsiu-Chun Lee, Taipei, TAIWAN;

Tse-Yao Huang, Taipei, TAIWAN;
Yi-Nan Chen, Taipei, TAIWAN;** CONTINUING DATA *Lee*
*NONE*** FOREIGN APPLICATIONS *Lee*
NONE

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 04/08/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY TAIWAN	SHEETS DRAWING 4	TOTAL CLAIMS 10	INDEPENDENT CLAIMS 2
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ADDRESS

23364
 BACON & THOMAS, PLLC
 625 SLATERS LANE
 FOURTH FLOOR
 ALEXANDRIA, VA
 22314

TITLE

Method for forming shallow trench in semiconductor device

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue)
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